



70 AF

PATENT  
8040-1052

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Taishi KUBOTA et al.

Conf. 8011

Application No. 10/763,244

Group 2823

Filed January 26, 2004

Examiner Trung Q. Dang

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE  
AND OXIDIZATION METHOD OF SEMICONDUCTOR  
SUBSTRATE

**RESPONSE AFTER FINAL REJECTION**

**MS AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 16, 2006

Sir:

This responds to the Official Action mailed May 17,  
2006.

**Remarks** begin on page 2 of this paper.